



**REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2851**

Attorney Docket: 081468-0308799  
Client Reference: P-1537.010-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:  
LEENDERS et al.

Confirmation Number: 4673

Application No.: 10/823,772

Group Art Unit: 2851

Filed: April 14, 2004

Examiner: Kim, Peter B.

Title: LITHOGRAPHIC APPARATUS, PROJECTION SYSTEM, METHOD OF  
PROJECTING AND DEVICE MANUFACTURING METHOD

**AMENDMENT AFTER FINAL REJECTION**  
**UNDER 37 C.F.R. §1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated March 6, 2006, the period for reply being extended by the Petition for One-Month Extension of Time filed herewith, please amend the above-identified application as follows:

*Please  
enter  
after-final  
amdt  
P/L  
8/31/06*